



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

May 14, 2025

IGI Report Number **LG704517661**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **12.45 X 8.95 X 6.06 MM**

GRADING RESULTS

Carat Weight **6.58 CARATS**

Color Grade **F**

Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

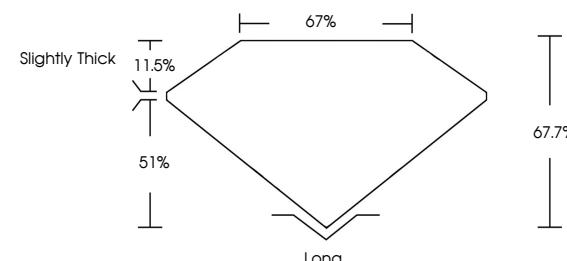
Symmetry **EXCELLENT**

Fluorescence **NONE**

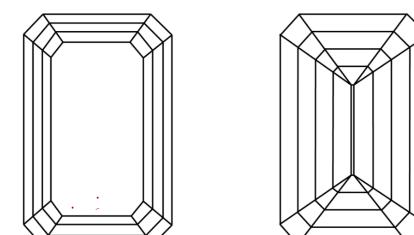
Inscription(s) **IGI LG704517661**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

www.igi.org

LG704517661
Report verification at igi.org

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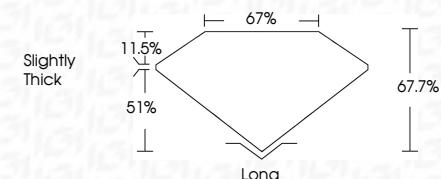
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Sample Image Used



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May 14, 2025	IGI Report No LG704517661	6.58 CARATS	F	VVS 2	67.7%	67.7%	Slightly Thick	Long	EXCELLENT	NONE	IGI LG704517661
		12.45 X 8.95 X 6.06 MM									
		Carat Weight		Color Grade		Clarity Grade		Depth		Table Grade	
		Cut		Polish		Symmetry		Fluorescence		Inscription(s)	

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Type IIa